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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450; Attention: Licensing and Review on April 9, 2004

William R. Allen, Reg. No. 48,389

_____Y April 2001

Date

Applicant:

David Fairbourn

Serial No:

10/613,620

Filing Date:

July 3, 2003

Art Unit: Examiner:

1763

Title:

Unknown
SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND

METHODS FOR DEPOSITING MULTIPLE-METAL ALUMINIDE

COATINGS

Atty Docket:

MTCL-09

Cincinnati, Ohio 45202

April 9, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attention: Licensing and Review

Sir:

RESPONSE TO NOTICE MAILED MARCH 4, 2004

In response to Notice mailed on March 4, 2004, Applicant hereby states that there is no relationship of the invention to the performance of any work under any contract or other arrangement with the National Aeronautics and Space Administration (NASA). A Property Rights Statement, executed by the inventor, setting forth the full facts concerning the circumstances under which the invention was made and conceived is attached hereto.

Applicant does not believe that any fees are due in connection with this submission. However, if such petition is due or any additional fees are necessary, the Commissioner may consider this to be a request for such and charge any necessary fees to Deposit Account No. 23-3000.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

William R. Allen, Reg. No. 48,389

2700 Carew Tower 441 Vine Street Cincinnati, OH 45202 (513) 241-2324

PATENT

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David Fairbourn

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SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Attention: Licensing and Review

PROPERTY RIGHTS STATEMENT

Sir:

I, David Fairbourn, a United States citizen, residing at 8790 South Tracy Drive, Sandy, Utah 84093, declare:

That I made and conceived the invention described and claimed in patent application Serial No. 10/613,620 filed in the United States of America on July 3, 2003 titled "Simple Chemical Vapor Deposition System and Methods for Depositing Multiple-Metal Aluminide Coatings;

That I made and conceived this invention while employed by Aeromet Technologies, Inc. (Sandy, Utah);

That the invention is related to the work I am employed to perform and was made within the scope of my employment duties;



That, to the best of my knowledge and belief, the invention was made during working hours and with the use of facilities, equipment, materials, funds, information and services of Aeromet Technologies, Inc.

The invention was not made (conceived or first actually reduced to practice) under nor is there any relationship of the invention to the performance of any work under any contract of the National Aeronautics and Space Administration.

The undersigned inventor declares further that all statements made herein of his own knowledge are true and that all statements made on information and belief are believed to be true and further that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Date: 30 March 2004

David C. Fairbourn 8790 South Tracy Drive Sandy, Utah 84093

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WOOD, HERRON & EVANS, LLP 2700 CAREW TOWER

CINCINNATI, OHIO 45202-2917

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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